

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: CHAD RUE, ET AL. )  
Serial No.: 10/711,691 ) Group Art Unit: 2881  
Filed: September 30, 2004 )  
For: APPARATUS AND METHOD FOR )  
MANIPULATING SAMPLE )  
TEMPERATURE FOR FOCUSED ION )  
BEAM PROCESSING ) Examiner: Yantorno, J.  
 ) Confirmation No.: 5690

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

In response to the Office Action mailed March 17, 2006, please amend the  
Application as follows: